



Dkt. 2271/53467-A1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Reissue Application of: Shunichi SATO

Reissue Application No.: 10/603,418

Filed: June 24, 2003

Original Patent No.: 5,904,549

Granted On: May 18, 1999

For: METHODS FOR GROWING SEMICONDUCTORS AND DEVICES THEREOF
FROM THE ALLOY SEMICONDUCTOR GaInNAs

Examiner: Laura M. Menz

Group Art Unit: 2813

Conf. No.: 9699

Class-Subclass: 438-478000

Issue Fee Due Date: July 20, 2010

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**APPLICANT'S COMMENTS ON
EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE**

Sir:

Applicant appreciates the Examiner's Statement of the Reasons for Allowance attached to the Notice of Allowability dated January April 20, 2010 and submits that the allowed claims recite subject matter which further supports patentability for reasons in addition to those identified in the Reasons for Allowance.

Respectfully submitted,

PAUL TENG, Reg. No. 40,837
Attorney for Applicant
COOPER & DUNHAM LLP
30 Rockefeller Plaza, 20th Floor
New York, New York 10112
Tel.: (212) 278-0400

| | |
|--|------|
| I hereby certify that this correspondence is being deposited this date with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. | |
| July 19, 2010 | |
| Paul Teng Reg. No. 40,837 | Date |